

<b>FORM PTO-1449 (SUBSTITUTE)</b>  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <b>INFORMATION DISCLOSURE          STATEMENT BY APPLICANT</b> (37 CFR 1.97(b)(1))				Attorney Docket No.: <b>2004P00018</b> Applicable No.: <b>Concurrently herewith</b>  Applicant <b>HIEROLD, Christofer, et al.</b>  Filing Date <b>September 5, 2006</b> Group Art Unit <b>2855</b>			
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EXAMINER INITIALS	PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
/PP/	A	2002/0167374 A1	11/2002	Hunt, et al.		
	B					
	C					
	D					
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FOREIGN PATENT DOCUMENT							
DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO		
J							
K							
L							
M							
N							

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		

  

EXAMINER /Punam Patel/	DATE CONSIDERED 08/26/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (SUBSTITUTE)

Attorney Docket No.:  
2004P00018Applic. No.  
10/591,879U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

Applicant

Christofer Hierold et al.

Filing Date  
September 5, 2006Group Art Unit  
~~N/A~~ PP  
2855INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR § 1.98(b))

## U.S. PATENT DOCUMENTS

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/PP/	N	Tombler et al.: "Reversible electromechanical characteristics of carbon nanotubes under local- probe manipulation", Nature, June 15, 2000
/PP/	O	Husain et al.: "Nanowire- based very- high- frequency electromechanical resonator", Applied Physics letters, August 11, 2003
/PP/	P	Toriyama Toshiyuki et al.: " Piezoresistance measurement on single crystal silicon nanowires", Journal of Applied Physics, January 1, 2003

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